

<p style="text-align: center;">REQUEST FOR CONTINUED EXAMINATION (RCE) TRANSMITTAL</p> <p>Subsection (b) of 35 U.S.C. § 132, effective on May 29, 2000, provides for continued examination of an utility or plant application filed on or after June 8, 1995. See The American Inventors Protection Act of 1999 (AIPA).</p>	<i>Application Number</i>	10/623,788
	<i>Filing Date</i>	July 21, 2003
	<i>First Named Inventor</i>	Leonard Forbes
	<i>Group Art Unit</i>	2822
	<i>Examiner Name</i>	Pamela Perkins
	<i>Attorney Docket Number</i>	1303.109US1
	<i>Customer No.</i>	73115

This is a Request for Continued Examination (RCE) under 37 C.F.R § 1.114 of the above-identified application entitled
STRAINED SEMICONDUCTOR BY FULL WAFER BONDING

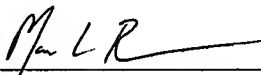
1. Submission required under 37 C.F.R. § 1.114:

- ☒ Amendment Under 37 C.F.R § 1.116 (20 pages) is enclosed.
- ☒ Information Disclosure Statement (2 pages), Form 1449 (1 page), and No copies of cited documents.

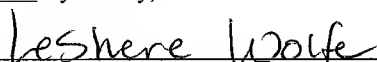
2. Fees

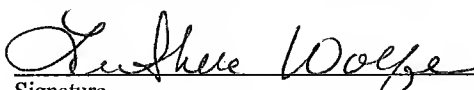
- ☒ Authorization to charge deposit account 19-0743 in the amount of \$810.00 to pay the RCE filing fee required under 37 C.F.R. § 1.17(e).
- ☒ Authorization to charge deposit account 19-0743 in the amount of \$420.00 for additional Independent claims
- ☒ **The Commissioner is hereby authorized to charge any additional fees or credit overpayment to Deposit Account No. 19-0743.**

SCHWEGMAN, LUNDBERG & WOESSNER, P.A.

By: 
Marvin L. Beekman
Reg. No. 38,377

CERTIFICATE UNDER 37 C.F.R 1.8: The undersigned hereby certifies that this correspondence is being filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 13th day of May, 2008.


Name


Signature